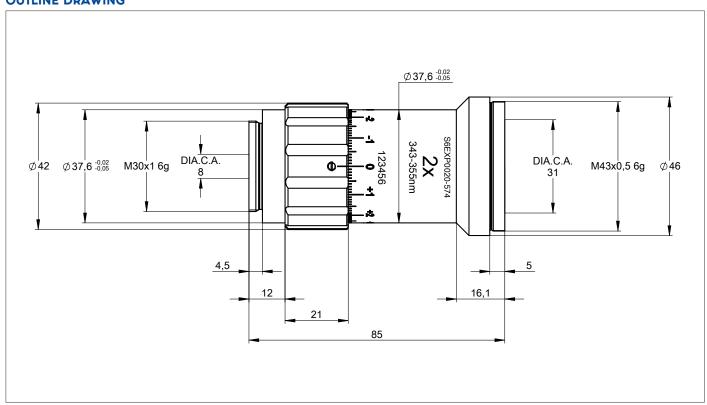
DATA SHEET

S6EXPOO20-574

BEAMEXPANDER MAGNIFICATION 2.0 FOR 343 - 355 nm FUSED SILICA



OUTLINE DRAWING



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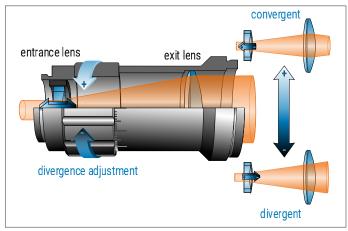


DATA SHEET

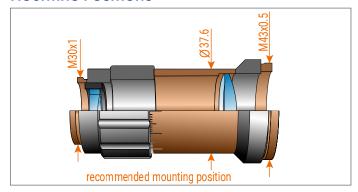
SPECIFICATIONS

article number	S6EXP0020-574
design wavelength [nm]	355
magnification factor	2.0
divergence adjustable	yes
optical principle	Galilei (no internal focus)
pointing stability [mrad]	<1
clear input aperture [mm]	8.0
clear output aperture [mm]	31.0
recommended beam-Ø [mm] ¹⁾	6.0
total number of lenses	3
total transmission [%]	> 98
lens material	fused silica
LIDT (coating) [J/cm²]	1.0 J/cm² per 1ns pulse at 50Hz
SP and USP usable	yes
SP and USP usable, reversed usage	no
mounting thread	M30x1
weight [kg]	0.2
accessory	S6MEC0127 - adapter M30x1 to C-mount

DIVERGENCE ADJUSTMENT



MOUNTING POSITIONS



REMARKS

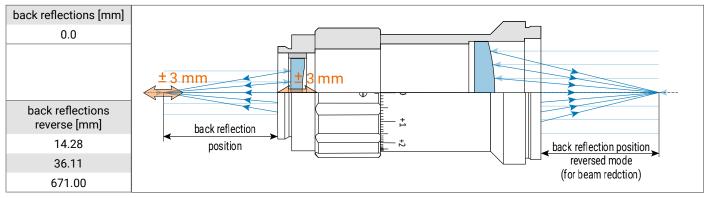
¹⁾clipped at 1/e²; wavefront error on axis (PV) < λ/10 (value provided by design)
magnification (reversed mode) = 1 / magnification (regular mode)
divergence adjustement = 0 → collimated input beam results in collimated output beam

maximum divergence adjustment is ± 3 mm

RoHS compliant

length at divergence setting "0" stated in the drawing - length extension of max. 3 mm is possible

BACK REFLECTION POSITION



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